

Special Issue

Progress in MEMS/NEMS Devices

Message from the Guest Editor

Ever since they first emerged as a spinoff from integrated circuit technology, MEMS/NEMS devices have experienced progress that has not only been remarkable but is still rapidly progressing. Worldwide, excellent research activities on MEMS/NEMS devices are steadily contributing to the progress of the state-of-the-art, and in this Special Issue, we will highlight work of excellence in the field. Potential topics include, but are not limited to, the keywords listed below:

- MEMS devices
- NEMS devices
- micro- and nanosystems
- Microsensors
- Microactuators
- Silicon micromachining
- Bulk micromachining
- Surface micromachining
- Front-end electronics
- Monolithic integration

Welcome to contribute!

Guest Editor

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Deadline for manuscript submissions

closed (31 October 2019)



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About the Journal

Message from the Editor-in-Chief

Electronics is a multidisciplinary journal designed to appeal to a diverse audience of research scientists, practitioners, and developers in academia and industry. The journal is devoted to fast publication of latest technological breakthroughs, cutting-edge developments, and timely reviews of current and emerging technologies related to the broad field of electronics. Experimental and theoretical results are published as regular peer-reviewed articles or as articles within Special Issues guest-edited by leading experts in selected topics of interest.

Editor-in-Chief

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manuscripts are peer-reviewed and a first decision is provided to authors approximately 16.8 days after submission; acceptance to publication is undertaken in 2.4 days (median values for papers published in this journal in the first half of 2025).